Substitute for Form 1449/PTO					Complete if Kn wn		
	INFO	2Ν/Δ	TION DISCLOSUR	Application Number	Not Yet Assigned		
				Filing Date	July 24, 2003		
	STAT	EME	ENT BY APPLICAN	First Named Inventor:	Kramadhati V. Ravi		
(use as many sheets as necessary)					Art Unit	Not Yet Assigned	
				Examiner Name	Not Yet Assigned		
Sh et	1	l of		2	Attorney Docket Number	042390P16670	
			U.S. PATE	NT DOCUMENTS	S		
Examiner Initials*	Cite No.1		Document Number  Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
20		1	•				
PD		US-	5,272,104	12-21-1993	Schrantz, et al.		
<del></del>		US-	5,650,639	07-22-1997	Schrantz, et al.		
		US-	5,696,665	12-09-1997	Nagy		
<del>\</del>		US-	6,051,063	04-18-2000	Tanabe, et al.		
V		US-	6,211,041 B1	04-03-2001	Ogura		
PD		US-	6,337,513 B1	01-08-2002	Clevenger, et al.		
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·	Ī	Foreign Patent Document	KEIGN PATEN	IT DOCUMENTS		
Examiner Initials*	Cite No. <sup>1</sup>	Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)	Publication Date  MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T۰
60		EP 0 814 509 A2	12-29-1997	Motorola, Inc./Pollock, et al.		
PD		PCT/US92/11068	07-07-1994	Harris Corp./Schrantz, et al.		
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	Not Yet Assigned			
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				First Named Inventor:	Kramadhati V	Kramadhati V. Ravi		
				Art Unit	Not Yet Assig	Not Yet Assigned		
				Examiner Name	Not Yet Assig	Not Yet Assigned		
Sheet	2	of	2	Attorney Docket Number	042390P1667	0		
			NON PATENT LIT	ERATURE DOCUMENTS				
Examiner Initials*	Cite No <sup>1</sup>						T²	
PP		LIU, HUIMIN and DANDY, DAVID S. <u>Diamond Chemical Vapor Deposition: Nucleation and Early Growth Stages</u> , 1995, pp. 1-7. Noyes Publications, Park Ridge, New Jersey, U.S.A.						
PD		WOLF, STANLEY, Ph.D. and TAUBER, RICHARD N., Ph.D. Silicon Processing for the VLSI Era – Volume 1: Process Technology, pp. 1-8. Lattice Press, Sunset Beach, California, U.S.A.						
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Examiner Signature		PHuc	T. DAN	G	Date Considered	11/12/0	4	

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